



Attorney Docket No. 0756-2393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ritsuko KAWASAKI et al.

Serial No. 09/988,389

Filed: November 19, 2001

For: LASER IRRADIATION METHOD AND  
METHOD OF MANUFACTURING A  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2818

) Examiner: D. Vu

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is  
) being deposited with the United States Postal  
) Service with sufficient postage as First Class  
) Mail in an envelope addressed to:  
) Commissioner for Patents, P.O. Box 1450,  
) Alexandria, VA 22313-1450, on

12/29/05

Rose J. Jones

*Enter  
w/RCE  
dated  
1-25-06*

**AFTER FINAL AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated September 28, 2005, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 23 of this paper.